

**Inventor Name Search Result**

Your Search was:

Last Name = FUKUNAGA

First Name = AKIRA

Application#	Patent#	Status	Date Filed	Title	Inventor Name 34
<u>60037469</u>	Not Issued	159	02/07/1997	EXHAUST APPARATUS IN ION IMPLANTATION SYSTEM	FUKUNAGA , AKIRA
<u>10629678</u>	Not Issued	020	07/30/2003	HOLDING UNIT, PROCESSING APPARATUS AND HOLDING METHOD OF SUBSTRATES	FUKUNAGA, AKIRA
<u>10464551</u>	Not Issued	030	06/19/2003	SOLUTION CONTAINING METAL COMPONENT, METHOD OF AND APPARATUS FOR FORMING THIN METAL FILM	FUKUNAGA, AKIRA
<u>10449515</u>	Not Issued	040	06/02/2003	ELECTROLYTIC MACHINING METHOD AND APPARATUS	FUKUNAGA, AKIRA
<u>10400436</u>	Not Issued	030	03/28/2003	METHOD AND APPARATUS FOR FORMING FINE CIRCUIT INTERCONNECTS	FUKUNAGA, AKIRA
<u>10390600</u>	Not Issued	093	03/19/2003	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	FUKUNAGA, AKIRA
<u>10315172</u>	Not Issued	071	12/10/2002	METHOD FOR MOUNTING A SEMICONDUCTOR DEVICE	FUKUNAGA, AKIRA
<u>10315170</u>	Not Issued	071	12/10/2002	METHOD AND APPARATUS OF PRODUCING THIN FILM OF METAL OR METAL COMPOUND	FUKUNAGA, AKIRA
<u>09996674</u>	6602396	150	11/30/2001	ELECTROLYTIC MACHINING METHOD AND APPARATUS	FUKUNAGA, AKIRA
<u>09994755</u>	Not Issued	094	11/28/2001	PLATING APPARATUS AND METHOD OF MANAGING PLATING LIQUID COMPOSITION	FUKUNAGA, AKIRA
<u>09988719</u>	Not Issued	071	11/20/2001	METHOD AND APPARATUS FOR ETCHING RUTHENIUM FILMS	FUKUNAGA, AKIRA
<u>09984791</u>	Not Issued	161	10/31/2001	HOLDING UNIT, PROCESSING APPARATUS AND HOLDING METHOD OF SUBSTRATES	FUKUNAGA, AKIRA
<u>09890330</u>	Not Issued	092	07/30/2001	METHOD AND APPARATUS FOR FORMING THIN FILM OF METAL	FUKUNAGA, AKIRA
<u>09868524</u>	6709555	150	06/19/2001	PLATING METHOD, WIRING FORMING METHOD AND DEVICES THEREFOR	FUKUNAGA, AKIRA
<u>09868140</u>	Not	095	06/15/2001	METHOD OF AND APPARATUS FOR	FUKUNAGA, AKIRA

	Issued			FORMING INTERCONNECTION	
<u>09820778</u>	Not Issued	071	03/30/2001	REACTIVE PROBE CHIP, COMPOSITE SUBSTRATE AND METHOD FOR FABRICATION OF THE SAME	FUKUNAGA, AKIRA
<u>09811581</u>	Not Issued	094	03/20/2001	COMPOSITE METALLIC ULTRAFINE PARTICLES AND PROCESS FOR PRODUCING THE SAME	FUKUNAGA, AKIRA
<u>09733084</u>	Not Issued	161	12/11/2000	SOLUTION CONTAINING METAL COMPONENT, METHOD OF AND APPARATUS FOR FORMING THIN METAL FILM	FUKUNAGA, AKIRA
<u>09731898</u>	<u>6519842</u>	150	12/08/2000	METHOD FOR MOUNTING A SEMICONDUCTOR DEVICE	FUKUNAGA, AKIRA
<u>09726552</u>	<u>6517642</u>	150	12/01/2000	METHOD AND APPARATUS OF PRODUCING THIN FILM OF METAL OR METAL COMPOUND	FUKUNAGA, AKIRA
<u>09679305</u>	<u>6558478</u>	150	10/06/2000	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	FUKUNAGA, AKIRA
<u>09645405</u>	<u>6368493</u>	150	08/25/2000	ELECTROLYTIC MACHINING METHOD AND APPARATUS	FUKUNAGA, AKIRA
<u>09401719</u>	<u>6554205</u>	150	09/23/1999	GAS POLISHING METHOD, GAS POLISHING NOZZLE AND POLISHING APPARATUS	FUKUNAGA , AKIRA
<u>09272170</u>	<u>6447632</u>	150	03/18/1999	APPARATUS AND NOZZLE DEVICE FOR GASEOUS POLISHING	FUKUNAGA , AKIRA
<u>09271903</u>	Not Issued	060	03/18/1999	GAS POLISHING METHOD AND APPARATUS	FUKUNAGA , AKIRA
<u>09271864</u>	<u>6315858</u>	150	03/18/1999	GAS POLISHING APPARATUS AND METHOD	FUKUNAGA , AKIRA
<u>09030833</u>	<u>6136213</u>	150	02/26/1998	GAS POLISHING METHOD, GAS POLISHING NOZZLE AND POLISHING APPARATUS	FUKUNAGA , AKIRA
<u>08848356</u>	<u>5894131</u>	250	02/07/1997	EXHAUST APPARATUS IN ION IMPLANTATION SYSTEM	FUKUNAGA , AKIRA
<u>08757667</u>	<u>5788828</u>	150	11/29/1996	APPARATUS FOR DETECTING ANIONS IN WATER	FUKUNAGA , AKIRA
<u>07818122</u>	Not Issued	161	01/08/1992	METHOD OF RENDERING HARMLESS THE WASTE GAS FROM CHEMICAL VAPOR DEPOSITION PROCESS	FUKUNAGA , AKIRA
<u>07813693</u>	<u>5169419</u>	150	12/27/1991	GAS ADSORBER FOR EXHAUST GAS	FUKUNAGA , AKIRA
<u>07248905</u>	<u>4906257</u>	150	09/23/1988	METHOD OF AND APPARATUS FOR TREATING WASTE GAS FROM SEMICONDUCTOR MANUFACTURING PROCESS	FUKUNAGA , AKIRA
<u>07235574</u>	<u>4861578</u>	150	07/26/1988	METHOD OF TREATING WASTE GAS	FUKUNAGA , AKIRA

07105239

4826805

150

10/07/1987

GAS ABSORBER

FUKUNAGA , AKIRA

**Inventor Search Completed:** No Records to Display.

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## Inventor Name Search Result

Your Search was:

Last Name = OHNO

First Name = HARUKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<a href="#">10390600</a>	Not Issued	093	03/19/2003	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	OHNO, HARUKO
<a href="#">10261670</a>	Not Issued	030	10/02/2002	SUBSTRATE PROCESSING APPARATUS AND METHOD	OHNO, HARUKO
<a href="#">09988719</a>	Not Issued	071	11/20/2001	METHOD AND APPARATUS FOR ETCHING RUTHENIUM FILMS	OHNO, HARUKO
<a href="#">09679305</a>	6558478	150	10/06/2000	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	OHNO, HARUKO

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## Inventor Name Search Result

Your Search was:

Last Name = KATAKABE

First Name = ICHIRO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 12
<a href="#">10482310</a>	Not Issued	019	01/01/0001	ELECTROLESS PLATING APPARATUS AND POST-ELECTROLESS PLATING CLEANING METHOD	KATAKABE, ICHIRO
<a href="#">10390600</a>	Not Issued	093	03/19/2003	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	KATAKABE, ICHIRO
<a href="#">10261670</a>	Not Issued	030	10/02/2002	SUBSTRATE PROCESSING APPARATUS AND METHOD	KATAKABE, ICHIRO
<a href="#">09988719</a>	Not Issued	071	11/20/2001	METHOD AND APPARATUS FOR ETCHING RUTHENIUM FILMS	KATAKABE, ICHIRO
<a href="#">09842650</a>	Not Issued	071	04/27/2001	REVOLUTION MEMBER SUPPORTING APPARATUS AND SEMICONDUCTOR SUBSTRATE PROCESSING APPARATUS	KATAKABE, ICHIRO
<a href="#">09679305</a>	<a href="#">6558478</a>	150	10/06/2000	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	KATAKABE, ICHIRO
<a href="#">08840697</a>	<a href="#">5943578</a>	150	04/25/1997	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE HAVING AN ELEMENT ISOLATING REGION	KATAKABE , ICHIRO
<a href="#">08689111</a>	<a href="#">5880032</a>	150	07/30/1996	METHOD AND APPARATUS FOR MANUFACTURING A SEMICONDUCTOR DEVICE	KATAKABE , ICHIRO
<a href="#">08662468</a>	Not Issued	161	06/13/1996	ELEMENT ISOLATION REGION IN SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	KATAKABE , ICHIRO
<a href="#">08451509</a>	<a href="#">5878191</a>	150	05/26/1995	HEAT TREATMENT APPARATUS FOR SEMICONDUCTOR WAFERS	KATAKABE , ICHIRO
<a href="#">08390529</a>	<a href="#">5643046</a>	150	02/17/1995	POLISHING METHOD AND APPARATUS FOR DETECTING A POLISHING END POINT OF A SEMICONDUCTOR WAFER	KATAKABE , ICHIRO
<a href="#">08329423</a>	<a href="#">5605488</a>	150	10/27/1994	POLISHING APPARATUS OF SEMICONDUCTOR WAFER	KATAKABE , ICHIRO

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Your Search was:

Last Name = KIHARA

First Name = SACHIKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<a href="#">10390600</a>	Not Issued	093	03/19/2003	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	KIHARA, SACHIKO
<a href="#">10261670</a>	Not Issued	030	10/02/2002	SUBSTRATE PROCESSING APPARATUS AND METHOD	KIHARA, SACHIKO
<a href="#">09988719</a>	Not Issued	071	11/20/2001	METHOD AND APPARATUS FOR ETCHING RUTHENIUM FILMS	KIHARA, SACHIKO
<a href="#">09679305</a>	<a href="#">6558478</a>	150	10/06/2000	METHOD OF AND APPARATUS FOR CLEANING SUBSTRATE	KIHARA, SACHIKO

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